

U.S. PATENT DOCUMENTS

Examiner Initial		Document Number	. Date Name		Class	Subclass	Filing Date if Appropriate	
he	1.	5,483,527	1/9/1996	Doshi et al.	370	60.1	12/21/1994	
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	Document Number	Date	Country	Class	Subclass	Translation		
						Yes	No	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc).

hc	4.	Office Action from Korean Patent Application No. KR2000-0022519, dated April 25, 2002, (with translation).								
EXAMI	NER		DATE CONSIDERED							
		Aryscho	3/4/05							

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication.

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Form PTO-1449 U.S. Department of Commerce								mmei	rce		Atty. Docket No. 067515.0146 (A34237) Serial No. 09/843,354						
(REV. 2-82) Patent and Trademark Office INFORMATION DISCLOSURE STATEMENT									MR	NT	Applicant Gye-Chool Lee						
BY APPLICANT (Use several sheets if necessary)											Filing Date April 26, 2001		Group 2662 RECEIVED				
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